

PATENT NUMBER and
ISSUE DATE

JC760 U.S. PRO
10/025322
12/18/01

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER MALDONADO
10025322	12/18/2001	438		2823	

**APPLICANTS: Kusumoto Naoto; Takayama Toru; Yonezawa Masato;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/390,513 09/03/1999
WHICH IS A CON OF 08/735,554 10/23/1996 PAT 6,027,960

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 7-302189 10/25/1995

JAPAN 7-303138 11/01/1995

PG-13 DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO
US USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no		079/7/076003/US3130/3134D
Initials and Acknowledged Examiners's initials		
TITLE : Laser annealing method and laser annealing device		
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim O.G.
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print I.
TERMINAL		Primary Examiner		Application Examiner
		PREPARED FOR ISSUE		